CL2000
Adaptable Die Bonder Platform
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The CL2000 multi-purpose die bonder is a system designed for customers in the semiconductor and photonics packaging market. It can be configured to a wide range of tasks in a wide range of production environments.

The base system provides everything needed for a tremendous range of applications. A pre-configured high precision gantry motion system carries the tools for die bonding or testing. Of course the machine is designed for industrial production environments. In combination with a selection of a variety of functional modules the system becomes your individual production cell.

**Built for Industrial Use**
- Rugged steel base production cell
- Hardware interlock circuit for save operation
- Ergonomic HUI
- Full featured machine switchboard
- Integrated air and vac control
- Operation console for comfort access of basic machine function

**Powerful Machine and Process Software**
- Remote service and control via internet
- Freely programmable machine processes
- User friendly user interface
- Line based process programming
- Recipe based management of process parameters
- Algorithms for active assembly
- SQL data base based storage of process parameters and component data
- Flexible data import and export
- Component tracking
- Same software on all ficonTEC machines for consistent look and feel of machine programming and operation

**Key Features**
- +/- 2 µm bonding accuracy
- Large number of functional application modules
- High precision 4 axes motion system, 3 lateral, 1 rotatory
- Industry grade machine enclosure, Laser Class 1
- Linear motor driven granite gantry for service less motion
- Square working area for complex and versatile packaging
- Epoxy or Eutectic bonding
- Process Control Master: Extremely powerful and versatile machine software

**High Precision Die Attach**

With the special bond head the CL2000 is perfectly suited for chip bonding. A specifically designed die handler holds the die while a dedicated bond camera observes the chip and the bond position on the substrate concurrently. This offers alignment distances during the assembly process for best bonding accuracy.
### Fields of Usage

- Si-Photonics components
- Sensor assemblies
- Medical devices
- MEMS/MOEMS
- Miniature lasers
- Hybrid assemblies
- LED print heads
- High power LEDs

### Modules

<table>
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<tr>
<th>Modules</th>
<th>Feature</th>
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| **Material Handling** | • Cassette-to-Cassette  
                      |   • In-Line  
                      |   • Conveyor  
                      |   • Robot loading  
                      |   • Tape and reel feeding  
                      |   • SMEMA Interfacing  
                      |   • Manual trayloading |
| **Laser Soldering** | • Fast soldering process for chips  
                      |   • E.g. COS (Chip on Submount)  
                      |   • Fiber coupled light delivery  
                      |   • Laser Class 1 operation |
| **Heating Plates** | • Conduction heating by heating plates  
                      |   • For soldering processes or thermal curing applications  
                      |   • Flexible temperature PID control of heating profile  
                      |   • Up to 450°C  
                      |   • Different oven sizes available |
| **Co-planarity Unit** | • For highest performance of chip to substrate parallelism  
                      |   • Especially suited for larger dies  
                      |   • Metrology for displacement  
                      |   • Actuation for correction of bond line uniformity |
| **Tool Changer Magazine** | • For the automatic change of handling tools  
                      |   • Tool magazine with up to 8 positions |
| **Wafer Processing** | • Handling table to process dies from or to wafers or wafer foil (BlueTape)  
                      |   • For up to 200 mm wafers  
                      |   • Ink dot detection  
                      |   • Wafer map reading and generation  
                      |   • Damage free die ejector |
| **Flip Chip Unit** | • For flipping chips during the assembly process  
                      |   • Smooth operation  
                      |   • No chip smashing |
| **Dispensing Unit** | • For the dispensing of e.g. epoxies  
                      |   • Controlled from within machine process |
| **UV Curing Unit** | • For the illumination with UV light  
                      |   • E.g. for curing of UV epoxies  
                      |   • One (standard) or up to four illumination spots  
                      |   • Controlled from within machine process |
| **Bonding Force Control** | • Closed-loop bond force control  
                      |   • For delicate components (GaAs, InP, MEMS)  
                      |   • For consistent bond result  
                      |   • Controlled from within machine process |
| **Pick-up Tool (PUT)** | • Different PUTs available  
                      |   • Glass, steel, rubber, plastic chosen for best application  
                      |   • Operated with vacuum |
What we do

ficonTEC designs and produces automated production equipment for the assembling or testing of components.

We are the market leader in the field of equipment for the assembly or test of micro-optics or opto-electronics such as laser diode manufacture, medical technology, security and military engineering, as well as telecommunications.

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